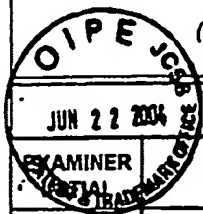


FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Docket Number (Optional) 81870.0027	Application Number 10/758,692
	Applicant SHODA, et al.	
	Filing Date January 15, 2004	Group Art Unit 2872



U.S. PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<i>MMC</i>	03/093898	11/13/03	WO			X	
<i>MMC</i>	2002-321947	11/08/02	JAPAN			Abstract	
<i>MMC</i>	2000-056265	02/25/00	JAPAN			Abstract	
<i>MMC</i>	08-146351	06/07/96	JAPAN			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>MMC</i>	HAISMA, et al., "Surface Preparation and Phenomenological Aspects of Direct Bonding" Philips Journal of Research, Elsevier, Amsterdam, NL, vol. 49, no. 1, 1995, pages 23-46

EXAMINER <i>MM/BL</i>	DATE CONSIDERED <i>6/16/2005</i>
EXAMINER: Initial citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	